



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 31, 2026	
IGI Report Number	LG834607508
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	MARQUISE BRILLIANT
Measurements	13.16 X 6.61 X 4.19 MM

GRADING RESULTS

Carat Weight	2.09 CARATS
Color Grade	E
Clarity Grade	VVS 2

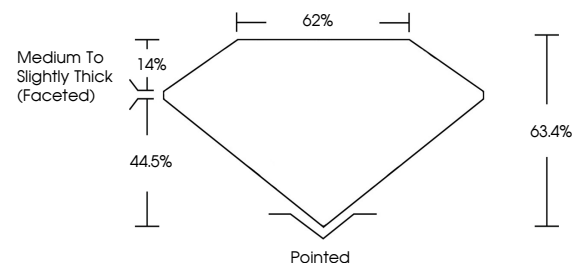
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG834607508

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

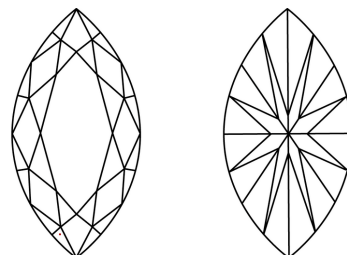
LG834607508
Report verification at igi.org

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

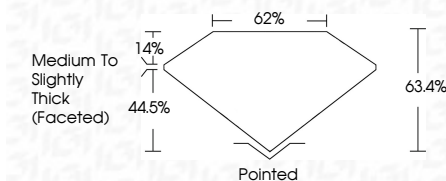
LABORATORY GROWN DIAMOND REPORT



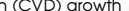
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www.igi.org

August 31, 2026	2.09 CARATS
GI Report No. LG834607508	VVS 2
MAQUINISE BRILLIANT	63.4%
	62%
	Medium to Slightly Thick Faceted
	Pointed
	EXCELLENT
	EXCELLENT
	NONE
	1891 LG834607508

Comments: Very Fine Growth Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIA